## Application/Control No. Applicant(s)/Patent Under Reexamination 09/895,353 AVERY ET AL. Notice of References Cited Examiner Art Unit Page 1 of 1 Shin-Hon Chen 2131 **U.S. PATENT DOCUMENTS Document Number** Date Classification Name Country Code-Number-Kind Code MM-YYYY 12-2002 382/124 US-6,496,595 Puchek et al. Α 709/219 03-2002 Gravlin, Keith Robert В US-6,353,853 С US-2002/0029349 03-2002 DAIGNEAULT et al. 713/200 12-2000 Hamid et al. 382/115 US-6,160,903 D 08-2001 Kimmel et al. 340/506 Ε US-6,281,790 F US-4,689,610 08-1987 Dietrich, William V. 340/515 US-5,541,585 G 07-1996 Duhame et al. 340/5.62 US-6,389,454 05-2002 Ralston et al. 709/204 US-US-J US-Κ US-L М US-**FOREIGN PATENT DOCUMENTS** Document Number Date Country Name Classification Country Code-Number-Kind Code MM-YYYY Ν 0 Р Q R S Т **NON-PATENT DOCUMENTS** Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages) U

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